

UNITED STATES DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

Inventors: HE, Ting et al.
Serial Number: 10/757,302
Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit: 1763
Examiner: Richard R. Bueker

Atty. Docket No.: 3994994-148069 CONFIRMATION NO. 4457

**Response to Notice of Non-Compliant Amendment Mailed 10/12/010 for
Amendment and Response to Office Action Mailed on June 25, 2010**

By E-file [registered user] on OCTOBER 20, 2010
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner:

In response to the Notice of Non-Compliant Amendment Mailed 10/12/010, please find the corrected claim set and response to Office Action Mailed on June 25, 2010. Entry of this corrected amendment, reexamination and reconsideration is requested.

1) Corrected Amendments to the Claims begin on page 2; and

3) Remarks begin on page 6.

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